

Notice of References Cited	Application/Control No. 10/698,421	Applicant(s)/Patent Under Reexamination IGARASHI ET AL.	
	Examiner Davienne Monbleau	Art Unit 2878	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,419,439	07-2002	Schlehahn et al.	414/331.18
*	B	US-6,452,201	09-2002	Wang et al.	250/559.29
*	C	US-6,403,945	06-2002	Roessler et al.	250/221
*	D	US-6,147,356	11-2000	Hahn et al.	250/559.29
*	E	US-5,605,428	02-1997	Birkner et al.	414/331.15
*	F	US-6,053,983	04-2000	Saeki et al.	118/728
*	G	US-6,470,927	10-2002	Otaguro, Tetsunori	141/98
*	H	US-6,655,423	12-2003	Rush et al.	141/98
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	JP 2001284439 A	10-2001	Japan	MIYAJIMA et al.	H01L 21/68
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.

DM 3-21-05